

Docket No.: 8733.977.00

(PATENT)

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

LEE, Yun Bok et al.

Customer No.: 30827

Application No.: 10/736,677

Confirmation No.: 4107

Filed: December 17, 2003

Art Unit: 2881

For: ION BEAM IRRADIATION DEVICE

Examiner: Kalimah Fernandez

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## **AMENDMENT**

Sir:

In response to the Office Action dated June 15, 2005, please amend the patent application identified above as follows:

## **INTRODUCTORY COMMENTS**

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.